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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): WAKASUGI et al.	Atty. Dkt.: 01-593
Serial No.: 10/814,513	Group Art Unit: 2855
Filed: April 1, 2004	Examiner: Unknown
Title: SEMICONDUCTOR PRESSURE SENSOR	

Commissioner for Patents
Alexandria, VA 22314

Date: February 9, 2006

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Sir:

Pursuant to 37 C.F.R. §1.56, the reference(s) listed on the attached Form PTO-1449 is/are being brought to the attention of the Examiner without any admission that it/they constitute(s) statutory prior art, or without any admission that it/they contain(s) subject matter that anticipates the invention or renders the invention obvious to a person of ordinary skill in the art.

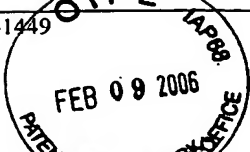
Further, pursuant to 37 C.F.R. §1.97(e), the undersigned hereby certifies that each of the listed reference(s) was first cited in a Communication (copy and translation enclosed) from a foreign patent office in connection with a counterpart foreign application not more than three months prior to the filing of this statement.

Although no fees are believed to be due at this time, it is respectfully requested that any such fees be charged to Deposit Account 50-1147. Also, the Examiner is requested to initial the attached PTO Form-1449 and to return a copy of same to the undersigned attorney as proof that the listed reference(s) has/have been considered and made of record.

Respectfully submitted,

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FORM PTO-1449		ATTY. DKT NO. 01-593	SER. NO. 10/814,513
		APPLICANT WAKASUGI et al.	
		FILING DATE April 1, 2004	GROUP 2855

REFERENCE DESIGNATION

U.S. PATENT DOCUMENTS

EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS

FOREIGN PATENT DOCUMENTS

TRANSLATION

		DOCUMENT NUMBER	DATE	COUNTRY	NAME	CLASS	SUB CLASS	YES	NO	
										Eng. Abstract
		JP-A-9-126927	5/16/97	JAPAN						X

* Full English text is available in machine-translated form in JPO (Japanese Patent Office) English language web site at <http://www1.ipdl.jpo.go.jp/PA1/cgi-bin/PA1INDEX>.

OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, etc.)

	Notice of Preliminary Rejection issued from Korean Patent Office issued on November 15, 2005 for the corresponding Korean patent application No. 10-2004-0021858 (a copy and English translation thereof)
EXAMINER	DATE CONSIDERED